

RADIATION HARDENED POWER MOSFET SURFACE MOUNT (SMD-2)

Product Summary

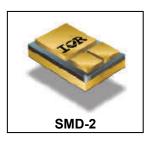
Part Number	Radiation Level	RDS(on)	Ι _D	QPL Part Number
IRHNA597064	100 kRads(Si)	0.016Ω	-56A	JANSR2N7524U2
IRHNA593064	300 kRads(Si)	0.016Ω	-56A	JANSF2N7524U2

60V, P-CHANNEL

JANSR2N7524U2

IRHNA597064

REF: MIL-PRF-19500/733



Pre-Irradiation

Description

IR HiRel R5 technology provides high performance power MOSFETs for space applications. These devices have been characterized for both Total Dose and Single Event Effect (SEE) with useful performance up to LET of 80 (MeV/(mg/cm²). The combination of low RDs(on) and low gate charge reduces the power losses in switching applications such as DC-DC converters and motor controllers. These devices retain all of the well established advantages of MOSFETs such as voltage control, fast switching, ease of paralleling and temperature stability of electrical parameters.

Features

- Single Event Effect (SEE) Hardened
- Low RDS(on)
- Low Total Gate Charge
- Simple Drive Requirements
- Ease of Paralleling
- Hermetically Sealed
- Electrically Isolated
- Ceramic Package
- Light Weight
- Surface Mount
- ESD Rating: Class 3A per MIL-STD-750, Method 1020

Absolute Maximum Ratings

	ings	FIE		
	Parameter		Units	
I _D @ V _{GS} = -12V, T _C = 25°C	Continuous Drain Current	-56*		
I _D @ V _{GS} = -12V, T _C = 100°C	Continuous Drain Current	-56*	A	
I _{DM} Pulsed Drain Current ①		-224		
P _D @T _C = 25°C	Maximum Power Dissipation	250	W	
	Linear Derating Factor	2.0	W/°C	
V _{GS}	Gate-to-Source Voltage	± 20	V	
E _{AS}	Single Pulse Avalanche Energy 2	725	mJ	
I _{AR}	Avalanche Current ①	-56	Α	
E _{AR}	Repetitive Avalanche Energy ①	25	mJ	
dv/dt	Peak Diode Recovery dv/dt 3	-2.1	V/ns	
TJ	Operating Junction and	-55 to + 150		
T _{STG}	Storage Temperature Range		°C	
	Lead Temperature	300 (for 5s)		
	Weight	3.3 (Typical)	g	

* Current is limited by package

For Footnotes, refer to the page 2.



Pre-Irradiation

	Parameter	Min.	Тур.	Max.	Units	Test Conditions
BV _{DSS}	Drain-to-Source Breakdown Voltage	-60			V	$V_{GS} = 0V, I_{D} = -1.0mA$
$\Delta BV_{DSS}/\Delta T_{J}$	Breakdown Voltage Temp. Coefficient		-0.064		V/°C	Reference to 25° C, I _D = -1.0mA
R _{DS(on)}	Static Drain-to-Source On-Resistance			0.016	Ω	V _{GS} = -12V, I _D = -56A ④
V _{GS(th)}	Gate Threshold Voltage	-2.0		-4.0	V	$V_{DS} = V_{GS}, I_{D} = -1.0 \text{mA}$
Gfs	Forward Transconductance	40			S	V _{DS} = -15V, I _D = -56A ④
I _{DSS}	Zara Cata Valtaga Drain Current			-10		$V_{DS} = -48V, V_{GS} = 0V$
	Zero Gate Voltage Drain Current			-25	μA	$V_{DS} = -48V, V_{GS} = 0V, T_{J} = 125^{\circ}C$
I _{GSS}	Gate-to-Source Leakage Forward			-100	nA	V _{GS} = -20V
	Gate-to-Source Leakage Reverse			100		V _{GS} = 20V
Q_{G}	Total Gate Charge			200		I _D = -56A
Q_{GS}	Gate-to-Source Charge			65	nC	V _{DS} = -30V
Q_{GD}	Gate-to-Drain ('Miller') Charge			60		V _{GS} = -12V
t _{d(on)}	Turn-On Delay Time			35		V _{DD} = -30V
tr	Rise Time			150	20	I _D = -56A
t _{d(off)}	Turn-Off Delay Time			100	ns	R _G = 2.35Ω
t _f	Fall Time			35		V _{GS} = -12V
Ls +L _D	Total Inductance		4.0		nH	Measured from center of Drain pad to center of Source pad
C _{iss}	Input Capacitance		7022			V _{GS} = 0V
C _{oss}	Output Capacitance		2897		pF	V _{DS} = -25V
C _{rss}	Reverse Transfer Capacitance		267			f = 1.0MHz

ctrical Characteristics @ Ti = 25°C (Unloss Otherwise Specified)

Source-Drain Diode Ratings and Characteristics

	Parameter		Тур.	Max.	Units	Test Conditions
I _S	Continuous Source Current (Body Diode)			-56	^	
I _{SM}	Pulsed Source Current (Body Diode) ①			-224	A	
V_{SD}	Diode Forward Voltage			-5.0	V	T _J =25°C, I _S = -56A, V _{GS} =0V④
t _{rr}	Reverse Recovery Time			200	ns	$T_J=25^{\circ}C, I_F = -56A, V_{DD} \le -25V$
Q _{rr}	Reverse Recovery Charge			500	nC	di/dt = -100A/µs
t _{on}	Forward Turn-On Time	Intrinsic turn-on time is negligible (turn-on is dominated by $L_{s}+L_{D}$)				

Thermal Resistance

	Parameter	Min.	Тур.	Max.	Units
$R_{ ext{ heta}JC}$	Junction-to-Case			0.5	°C/W
$R_{\theta J-PCB}$	Junction-to-PC Board (Soldered to 2" sq copper clad board)		1.6		C/W

Footnotes:

① Repetitive Rating; Pulse width limited by maximum junction temperature.

 $@~V_{\text{DD}}$ = -30V, starting T_{J} = 25°C, L = 0.46mH, Peak I_L = -56A, V_{GS} = -12V

3 $~I_{SD} \leq~$ -56A, di/dt $~\leq~$ -360A/µs, V_{DD} $~\leq~$ -30V, $T_{J} \leq 150^{\circ}C$

Pulse width \leq 300 µs; Duty Cycle \leq 2% 4

Total Dose Irradiation with V_{GS} Bias. -12 volt V_{GS} applied and V_{DS} = 0 during irradiation per MIL-STD-750, Method 1019, condition A. (5)

 \odot Total Dose Irradiation with V_{DS} Bias. -48 volt V_{DS} applied and V_{GS} = 0 during irradiation per MIL-STD-750, Method 1019, condition A.



Radiation Characteristics

IR HiRel radiation hardened MOSFETs are tested to verify their radiation hardness capability. The hardness assurance program at IR Hirel is comprised of two radiation environments. Every manufacturing lot is tested for total ionizing dose (per notes 5 and 6) using the TO-3 package. Both pre- and post-irradiation performance are tested and specified using the same drive circuitry and test conditions in order to provide a direct comparison.

Table1. Electrical Characteristics @ Tj = 25°C, Post Total Dose Irradiation \$6

	Parameter	100 kRads (Si) ¹		300 kRads (Si) ²		Units	Test Conditions	
		Min.	Max.	Min.	Max.			
BV_{DSS}	Drain-to-Source Breakdown Voltage	-60		-60		V	$V_{GS} = 0V, I_{D} = -1.0mA$	
$V_{GS(th)}$	Gate Threshold Voltage	-2.0	-4.0	-2.0	-5.0	V	V_{DS} = V_{GS} , I_D = -1.0mA	
I _{GSS}	Gate-to-Source Leakage Forward		-100		-100	nA	V _{GS} = -20V	
I _{GSS}	Gate-to-Source Leakage Reverse		100		100	nA	V _{GS} = 20V	
I _{DSS}	Zero Gate Voltage Drain Current		-10		-10	μA	V_{DS} = -48V, V_{GS} = 0V	
R _{DS(on)}	Static Drain-to-Source ④ On-State Resistance (TO-3)		0.016		0.016	Ω	V _{GS} = -12V, I _D = -56A	
R _{DS(on)}	Static Drain-to-Source ④ On-State Resistance (SMD-2)		0.016		0.016	Ω	V _{GS} = -12V, I _D = -56A	
V_{SD}	Diode Forward Voltage ④		-5.0		-5.0	V	$V_{GS} = 0V, I_{D} = -56A$	

1. Part numbers IRHNA597064, JANSR2N7524U2

2. Part numbers IRHNA593064, JANSF2N7524U2

IR HiRel radiation hardened MOSFETs have been characterized in heavy ion environment for Single Event Effects (SEE). Single Event Effects characterization is illustrated in Fig. a and Table 2.

Table 2. Typical Single Event Effect Safe Operating Area

		Damas	-	-	VDS (V)		
LET (MeV/(mg/cm²))	Energy (MeV)	Range (µm)	@ VGS = 0V	@ VGS =5V	@ VGS =10V	@ VGS =15V	@ VGS =20V
38 ± 5%	270 ± 7.5%	35 ± 7.5%	-60	-60	-60	-60	-60
61 ± 5%	330 ± 7.5%	31 ± 7.5%	-60	-60	-60	-45	-25
84 ± 5%	350 ± 7.5%	28 ± 7.5%	-60	-60	-60		

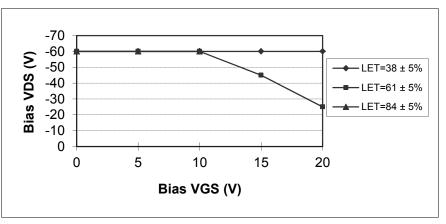


Fig a. Typical Single Event Effect, Safe Operating Area

For Footnotes, refer to the page 2.



Pre-Irradiation

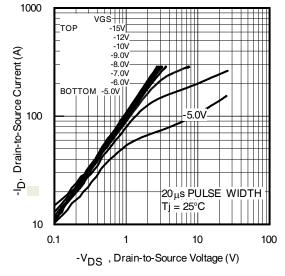


Fig 1. Typical Output Characteristics

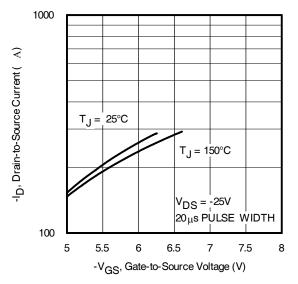
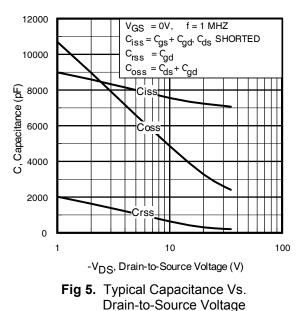


Fig 3. Typical Transfer Characteristics



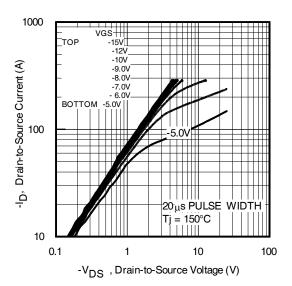


Fig 2. Typical Output Characteristics

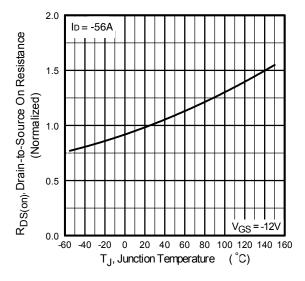
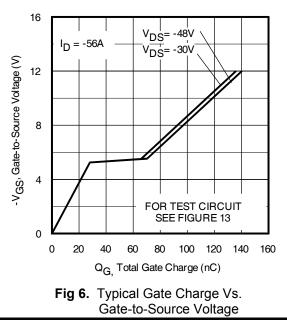


Fig 4. Normalized On-Resistance Vs. Temperature





Pre-Irradiation

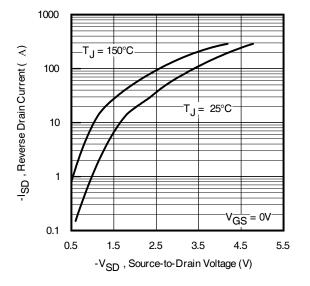


Fig 7. Typical Source-Drain Diode Forward Voltage

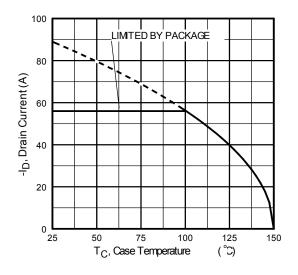


Fig 9. Maximum Drain Current Vs. Case Temperature

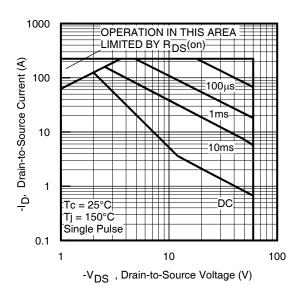


Fig 8. Maximum Safe Operating Area

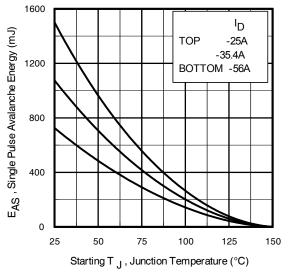
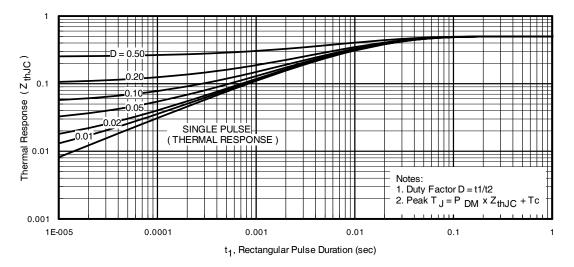


Fig 10. Maximum Avalanche Energy Vs. Drain Current







Pre-Irradiation

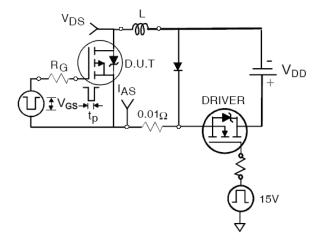
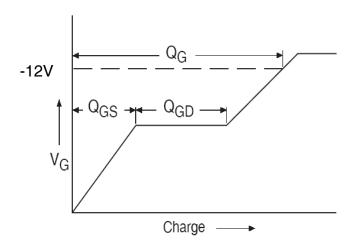
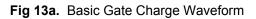


Fig 12a. Unclamped Inductive Test Circuit





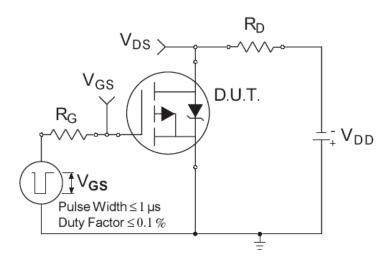
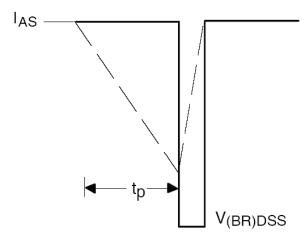
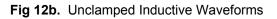


Fig 14a. Switching Time Test Circuit





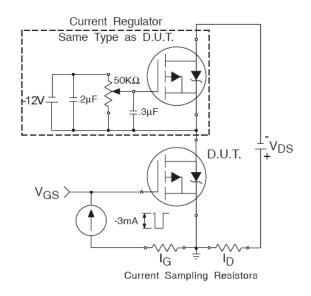


Fig 13b. Gate Charge Test Circuit

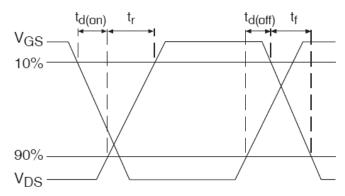
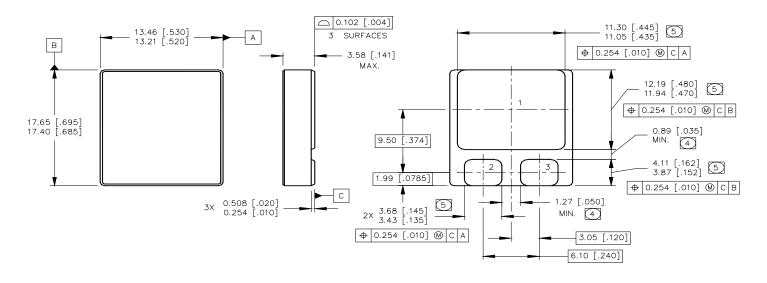


Fig 14b. Switching Time Waveforms



Pre-Irradiation

Case Outline and Dimensions — SMD-2



NOTES:

- 1. DIMENSIONING & TOLERANCING PER ASME Y14.5M-1994.
- 2. CONTROLLING DIMENSION: INCH.
- 3. DIMENSIONS ARE SHOWN IN MILLIMETERS [INCHES].
- 4) DIMENSION INCLUDES METALLIZATION FLASH.
- 5) DIMENSION DOES NOT INCLUDE METALLIZATION FLASH.

PAD ASSIGNMENTS

- MOSFET
- 1 = DRAIN
- 2 = GATE
- 3 = SOURCE



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